



Metrics Japan TC Chapter Meeting Summary and Minutes

Japan Summer Meetings 2024
Friday, July 26, 2024 15:00-17:00 JST
SEMI Japan Office, Tokyo, Japan/ OVTCCM (Hybrid)

TC Chapter Announcements

Next TC Chapter Meeting

Wednesday, December 11, 2024, 14:30-16:30 (JST)

Tokyo Big Sight, Tokyo, Japan/ OVTCCM (Hybrid)

in conjunction with SEMICON Japan 2024

Table 1 Meeting Attendees

Italics indicate virtual participants.

Co-Chairs: Mitsune Sakamoto (Zama Consulting)

SEMI Staff: Hiroshi Sato (SEMI Japan)

<i>Company</i>	<i>Last</i>	<i>First</i>	<i>Company</i>	<i>Last</i>	<i>First</i>
DAIFUKU	Suzuki	Tomoko	Tokyo Electron	Mochizuki	Tadashi
KOKUSAI ELECTRIC	Matsuda	Mitsuhiro	Zama Consulting	Sakamoto	Mitsune
SCREEN Semiconductor Solutions	Nishimura	Takayuki			
Tokyo Electron	Hama	Naoya	SEMI Japan	Kanno	Hirofumi
Tokyo Electron	Mashiro	Supika	SEMI Japan	Sato	Hiroshi

Table 2 Leadership Changes

<i>WG/TF/SC/TC Name</i>	<i>Previous Leader</i>	<i>New Leader</i>
None		

Table 3 TC Chapter Structure Changes

<i>Previous WG/TF/SC Name</i>	<i>New WG/TF/SC Name or Status Change</i>
ESD/ESC Task Force	Disbanded

Table 4 Ballot Results

<i>Document #</i>	<i>Document Title</i>	<i>Committee Action</i>
None		

#1 **Passed** ballots and line items will be submitted to the ISC Audit & Review Subcommittee for procedural review.

#2 **Failed** ballots and line items were returned to the originating task forces for re-work and re-balloting or abandoning.

Table 5 Ratification Ballot Results

<i>Document #</i>	<i>Document Title</i>	<i>ISC A&R Action</i>	<i>A&R Forms</i>
None			

Note 1: **Passed** Ratification ballots will be submitted to SEMI publication for final processing.

Note 2: **Failed** Ratification ballots were returned to the originating task forces for re-work and re-balloting or abandoning.

Table 6 Activities Approved by the GCS between meetings of the TC Chapter

<i>#</i>	<i>Type</i>	<i>SC/TF/WG</i>	<i>Details</i>
None			

Table 7 Authorized Activities

Listing of all revised or new SNARF(s) approved by the Originating TC Chapter.

<i>#</i>	<i>Type</i>	<i>SC/TF/WG</i>	<i>Details</i>
None			

#1 SNARFs and TFOFs are available for review on the SEMI Web site at:

<http://downloads.semi.org/web/wstdsbal.nsf/TFOFSNARF>

Table 8 Authorized Ballots

<i>#</i>	<i>When</i>	<i>TF</i>	<i>Details</i>
None			

Table 9 SNARF(s) Granted a One-Year Extension

<i>#</i>	<i>TF</i>	<i>Title</i>	<i>Expiration Date</i>
None			

Table 10 SNARF(s) Abolished

<i>#</i>	<i>TF</i>	<i>Title</i>
None		

Table 11 Standard(s) to receive Inactive Status

<i>Standard Designation</i>	<i>Title</i>
None	

Table 12 New Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
Jul26-2024#1	Hiroshi Sato	In considering the disband of the International Environmental Contamination Control (ECC) Task Force, check to see if the International ECC Task Force (Global TF) has already been disbanded.

Table 13 Previous Meeting Action Items

<i>Item #</i>	<i>Assigned to</i>	<i>Details</i>
None		

1 Welcome, Reminders, and Introductions

Mitsune Sakamoto (Zama Consulting) called the meeting to order at 15:00. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

Attachment: 01_Meeting Reminders

2 Review of Previous Meeting Minutes

The TC Chapter reviewed the minutes of the previous meeting.

Motion: Approve the minutes as written.

By / 2nd: Supika Mashiro (Tokyo Electron) / Takayuki Nishimura (SCREEN Semiconductor Solutions)

Discussion: None.

Vote: 5-Y 0-N. Motion passed.

Attachment: 02_20231213_Metrics_Min_approved

3 Liaison Reports

3.1 North America TC Chapter Report

Mitsune Sakamoto (Zama Consulting) reported for Cycle 5 Ballot Results and Cycles 6 to 8 will post two New Standards.

Attachment: 03_NA Metrics Report July-2024

4 SEMI Staff Report

Hiroshi Sato (SEMI Japan) gave the SEMI Staff Report. Of note:

- New online voting system went live for Cycle 3, 2024. This integrates and streamlines sign-in process with various SEMI/Standards member services, and improves data management for SEMI internal database. It is also expected to bring updated user interface while maintaining functionality that's familiar to voters.
- SEMI Standards Regulations and Procedure Manual were updated in February 2024. They are available at www.semi.org/standards (under Tools for Developing Standards).
- TFs have one year from 02/20/24 to implement use of Connect@SEMI (<https://connect.semi.org>) for TF management and document development depository. Once TFs have implemented use of Connect@SEMI, they shall use it to: maintain the TF member roster up to date, share the working drafts in PDF, and distribute the Draft Document at least one week before ballot submission to SEMI.
- Meeting Required Elements have been updated to include notice on confidential information.

Attachment: 04_Staff Report March 2024

5 Ballot Review

None.

6 Subcommittee and Task Force Reports

6.1 ESD/ESC TF

In line with ¶6.4.5.10 of the Procedures Manual, was complemented by Mitsuhiro Matsuda's (KOKUSAI ELECTRIC) motion to disband the TFOF due to the ESD/ESC TF being leaderless and inactive for over three years.

Motion: Disband the TFOF for ESD/ESC TF

By / 2nd: Mitsuhiro Matsuda (KOKUSAI ELECTRIC) / Takayuki Nishimura (SCREEN Semiconductor Solutions)

Discussion: No activity for more than 3 years.

Vote: 6-Y 0-N. Motion passed.

6.2 International Environmental Contamination Control (ECC) TF

Mitsune Sakamoto (Zama Consulting) has mentioned the inactive status of the International ECC TF (Global TF) and suggested that SEMI staff should verify this status, and if the dissolution has not yet occurred, Sakamoto proposes to bring a motion to the GCS.

6.3 Japan RF Measurement Liaison TF

Supika Mashiro (Tokyo Electron) submitted a proof of SEMI E113 and will propose a revision ballot after publication, also reported that discussing with NA members the possibility of making the RF Measurement TF a Global TF.

7 Old Business

7.1 Project Period Review

- Document Number: 6550, SNARF for: Revision to SEMI E113-0306 (Reapproved 0518), Specification for Semiconductor Processing Equipment RF Power Delivery Systems.

→ Since the development of the standards has been completed, this SNARF is closed.

7.2 5-year Review

None

8 New Business

None.

9 Action Item Review

9.1 Open Action Items

Item #	Assigned to	Details
None		

9.2 New Action Items

Item #	Assigned to	Details
Jul26-2024#1	Hiroshi Sato	In considering the disband of the International Environmental Contamination Control (ECC) Task Force, check to see if the International ECC Task Force (Global TF) has already been disbanded.



10 Next Meeting and Adjournment

The next meeting is scheduled for Wednesday, December 11, 2024, 14:30-16:30 (JST) at Tokyo Big Sight, Tokyo, Japan in conjunction with SEMICON Japan 2024 and via OVTCCM.

See <http://www.semi.org/standards-events> for the current list of events.

Adjournment: [17:00].

Respectfully submitted by:

Hiroshi Sato

Standards & EHS

SEMI Japan

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Minutes tentatively approved by:

Mitsune Sakamoto (Zama Consulting), Chair	Tuesday, July 30, 2024
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Table 14 Index of Available Attachments^{#1}

<i>Title</i>	<i>Title</i>
01_Meeting Reminders	03_NA Metrics Report July-2024
02_20231213_Metrics_Min_approved	04_Staff Report March 2024

^{#1} Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact Hiroshi Sato at the contact information above.